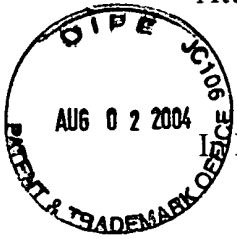


Attorney's Docket No.: 4733USA/W-C/W-C/JB1

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of:

Steven Verhaverbeke et al.

U.S. Serial No: 09/892,130

Filed: June 25, 2001

For: ASSISTED RINSING IN A SINGLE
WAFER CLEANING PROCESS

Examiner: Markoff, Alexander

Art Unit: 1746

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed March 29, 2004. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
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Attorney Docket: 4733USA/W-C/W-C/JB1
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